

Notice of References Cited	Application/Control No. 10/695,485	Applicant(s)/Patent Under Reexamination PAIK ET AL.	
	Examiner Rodney G. McDonald	Art Unit 1753	Page 1 of 1

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	B	US-6,800,177	10-2004	Shin et al.	204/192.16
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NON-PATENT DOCUMENTS

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	U	Abstract of 2003-016044 Korea
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